



TRANSMITTAL OF FORMAL DRAWINGS

Docket No.
OKI.313

In Re Application Of: Noriyuki Miura

Application No.	Filing Date	Confirmation No.	Examiner	Customer No.	Group Art Unit
10/092,499	03/08/200	1269	Le, Dung Anh	20987	2818

Invention: METHOD OF MANUFACTURING A SILICON-ON-INSULATOR (SOI) SEMICONDUCTOR DEVICE

Address to:
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Transmitted herewith are:

16 sheets of formal drawing(s) for this application.

Each sheet of drawing indicates the identifying indicia suggested in 37 CFR Section 1.84(c).

Signature

ADAM C. VOLENTINE
REG. NO. 33289

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Dated: AUGUST 9, 2004

I certify that this document and attached formal drawings are being deposited on [redacted] with the U.S. Postal Service as first class mail under 37 C.F.R. 1.8 and addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Signature of Person Mailing Correspondence

Typed or Printed Name of Person Mailing Correspondence